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## BIB DATA SHEET

CONFIRMATION NO. 7470

SERIAL NUMBER	FILING or 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.
10/522,717	08/24/2005	134	1792	ABE-030
<b>RULE</b>				
<b>APPLICANTS</b> Makoto Takemura, Tokyo, JAPAN; Yasuo Fukuda, Tokyo, JAPAN; Kazuaki Souda, Tokyo, JAPAN; Masaaki Kato, Kanagawa, JAPAN; Eiji Suhara, Tokyo, JAPAN;				
<b>** CONTINUING DATA *****</b> This application is a 371 of PCT/JP03/10254 08/11/2003 /N.B./ 10-20-2009				
<b>** FOREIGN APPLICATIONS *****</b> JAPAN 2002-235425 08/13/2002 /N.B./ 10-20-2009				
<b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b>				
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/Nicole Blau/</u> <small>Examiner's Signature</small>	<input type="checkbox"/> Met after Allowance <u>Initials</u>	<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 5	<b>TOTAL CLAIMS</b> 29
<b>INDEPENDENT CLAIMS</b> 3				
<b>ADDRESS</b> KUBOVCIK & KUBOVCIK SUITE 1105 1215 SOUTH CLARK STREET ARLINGTON, VA 22202 UNITED STATES				
<b>TITLE</b> Technique on ozone water for use in cleaning semiconductor substrate				
<b>FILING FEE RECEIVED</b> 1480	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit	